



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:     DAVID A. PALSULICH ET AL.  
APPLICATION No.:            10/636,021  
FILED:                         AUGUST 6, 2003  
FOR:     **MICROFEATURE WORKPIECE  
PROCESSING SYSTEM FOR, E.G.,  
SEMICONDUCTOR WAFER ANALYSIS**

EXAMINER:     ERIC B. CHEN  
ART UNIT:       1765  
CONF. NO:       1017

**Amendment Under 37 C.F.R. § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated May 9, 2005 in the above-identified application. Please extend the period of time for response to this Office Action by one month, to expire September 9, 2005. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.